



In re application of: Kim et al.

Serial No.: 10/787,368

Group: Art Unit 1752

Filed: February 26, 2004

Examiner: Walke, Amanda C.

For: **METHOD OF FORMING AN UNDERLAYER OF A BILAYER RESIST FILM
AND METHOD OF FABRICATING A SEMICONDUCTOR DEVICE USING
THE SAME**Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450**AMENDMENT TRANSMITTAL FORM**

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
					OR RATE
					ADDIT. FEE
TOTAL	27 *	MINUS	33** = 0	X 25	\$ 0 X 50 \$.00
INDEP.	5*	MINUS	6*** = 0	X 100	\$ 0 X 200 \$.00
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				X 180	\$ X 360 \$
TOTAL					OR TOTAL \$.00
ADDIT. FEE					\$.00

*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

** If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

*** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- ☐ Please charge Deposit Account No. _____ in the amount of \$____. Two (2) copies of this sheet are enclosed.
- ☐ Please charge fee of \$.00 for additional claims by Credit Card Payment Form PTO-2038 enclosed herewith
- ☒ Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. **50-0679**. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. **50-0679** therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

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Respectfully submitted,

Scott L. Appelbaum
Reg. No. 41,587
Attorney for Applicant**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)**I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313 on **July 11, 2006**.Dated: 7/11/06
Scott L. Appelbaum



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hyun-Woo Kim et al. Examiner: Amanda C. Walke
Serial No: 10/787,368 Group Art Unit: 1752
Filed: February 26, 2004 Docket: 8028-42 (SPX200304-0017US)
For: **METHOD OF FORMING AN UNDERLAYER OF A BI-LAYER RESIST FILM AND METHOD OF FABRICATING A SEMICONDUCTOR DEVICE USING THE SAME**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This paper is being filed in response to the Final Office Action mailed on May 16, 2006.

CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on **July 11, 2006**.

Dated: _____

7/11/06

Scott L. Appelbaum